



Image AF/2814  
Attorney's Docket No.: -07977-010004 / US2941D1D1 \$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto et al. Art Unit : 2814  
Serial No. : 09/903,339 Examiner : Theresa T. Doan  
Filed : July 10, 2001  
Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM  
SEMICONDUCTOR DEVICE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

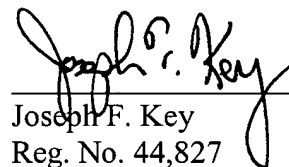
PETITION FOR TWO-MONTH EXTENSION OF TIME

Pursuant to 37 CFR §1.136, applicants hereby petition that the period for response to the action dated July 16, 2003, be extended for two months to and including December 16, 2003.

Enclosed is a check for \$420 for the required fee. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 12/16/2003

  
Joseph F. Key  
Reg. No. 44,827

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